

**Search Notes**

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Chong H. Kim

Applicant(s)/Patent under  
Reexamination

CHU, WEN-HWA LIN

Art Unit

3682

**SEARCHED**

Class	Subclass	Date	Examiner
74	594.4- 594.7	3/15/2006	CK

**INTERFERENCE SEARCHED**

Class	Subclass	Date	Examiner

**SEARCH NOTES  
(INCLUDING SEARCH STRATEGY)**

	DATE	EXMR